

JUN 20 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Tue Nguyen, Tai Dung Nguyen
Appln. No.: 10/790,652
Confirm. No.: 9765
Filed: March 1, 2004
Title: NANOLAYER THICK FILM PROCESSING
SYSTEM AND METHOD

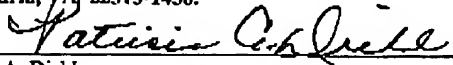
PATENT APPLICATION

Art Unit: 2812
Examiner: Nguyen, Ha T.

Customer No. 23910

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

 (Signature)
Patricia A. Diehl
Signature Date: 6-20-06

RESPONSE TO OFFICE ACTION

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of March 20, 2006, please amend the above-identified application as followed:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.